

Form PTO-1449UC95 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1398		SERIAL NO. 09/536,037	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Waimin (Michael) Li et al.	
				FILING DATE March 27, 2000	
				GROUP 2822	

U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	6,318,122	02/03	Chan et al.				
AB	6,492,688	12/02	Ilg (ILO)				
AC	6,373,114	04/02	Jeng et al.				
AD	6,001,747	12/14/1999	Annapragada				
AE	2001/0019668	9/01	Gonzalez et al.				
AF	2001/0003064	6/01	Ohto				
AG	2003/0013311	1/03	Chang et al.				
AH							
AI							
AJ							
AK							
AL							

FOREIGN PATENT DOCUMENTS								
	Document Number	Date	Country	Class	Subclass	Translation		
						Yes	No	
AM								
AN								
AO								
AP								
AQ								

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)			
AR		"Silicon Processing for The VLSI Era"; Wolf, Stanley, Ph.D., Lattice Press 1986	
AS			
AT			

EXAMINER	DATE CONSIDERED
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
MI22-1398SERIAL NO.
09/538,037LIST OF ART CITED BY APPLICANT
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Weimin (Michael) Li et al.FILING DATE
March 27, 2000GROUP
2822

U.S. PATENT DOCUMENTS

		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	AA	4,474,975	10-2-1984	Clemons et al.			
	AB	5,962,581	10-5-1999	Hayase et al.			
	AC	4,805,683	2-21-1989	Magdo et al.			
	AD	5,874,367	2-23-1999	Dobson			
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	AF	5,219,813	6-15-1993	Fabry et al.			
	AG	5,270,267	12-14-1993	Quellat			
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	AK	4,648,904	3-10-1987	DePasquale et al.			
	AL	4,158,717	6-19-1979	Nelson			
	AM	5,667,015	8-16-1997	Harsted et al.			
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	AR	4,600,671	7-15-1986	Saitoh et al.			
	AS	5,753,320	5-19-1998	Mikoshiba et al.			
	AT	5,356,515	10-18-1994	Tahara et al.			
	AU	4,954,867	9-4-1990	Hosaka			
	AV	5,674,358	10-7-1997	Nagayama			
	AW	5,731,242	3-24-1998	Parat et al.			
	AX	5,741,721	4-21-1998	Stevens			


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Sheet 1 of 1

		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1398		SERIAL NO. 09/035,007	
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Wolfe (Michael) U et al.		FILING DATE March 17, 2002	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	AA	6,001,747	12/14/1999	ANDAPRAGADA	438	790	
	AB						
	AC						
	AD						
	AE						
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	AI						
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FOREIGN PATENT DOCUMENTS							
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	AP						
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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